



33082M298

PATENT

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tsuneyuki Okabe, et al.

U.S. Serial No.: 10/564,558

Group Art Unit: To Be Assigned

Filed: : January 13, 2006

Examiner: To Be Assigned

For: SEMICONDUCTOR MANUFACTURING APPARATUS AND
SEMICONDUCTOR MANUFACTURING METHOD

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and a copy of the documents cited therein. The two Japanese documents were cited and discussed on pages 3 and 4 of Applicants' specification.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed before receipt of the initial Office Action in the present application, and therefore it is believed that no fees are due under 37 C.F.R. Section 1.97(i).

Respectfully submitted,
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May 8, 2006



FORM PTO-1449

INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET
033082M298SERIAL NO.
10/564,558

APPLICANT:

Tsuneyuki OKABE, et al.

FILING DATE
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U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
	AH	07-263350	10/13/95	Japan			Abstract
	AI	05-289751	11/5/93	Japan			Abstract
	AJ						
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	

EXAMINER:

DATE CONSIDERED:

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.